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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

OKU et al

Serial No.: 09/903,764

Filed: July 13, 2001

For: FILM FORMING METHOD,
SEMICONDUCTOR DEVICE AND
SEMICONDUCTOR DEVICE
MANUFACTURING METHOD

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) Examiner: K. Nguyen
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) Art Unit: 2823 /
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INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97(c)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

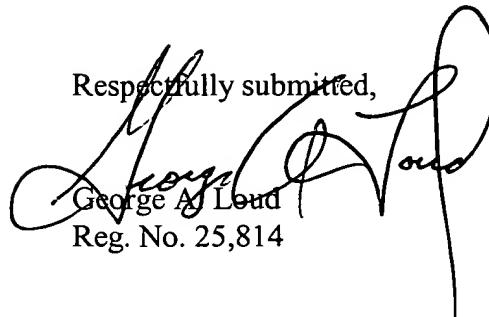
It is respectfully requested that the examiner consider and cite of record EP 851480 and U.S. 6,133,162. A copy of EP 851480 is submitted herewith.

Also submitted herewith is a copy of a Japanese Office Action dated February 17, 2004 and issued in connection with Japanese Application 2001-220232 believed to correspond to the captioned application. Note that Kokai 7-211712 corresponds to U.S. 5,554,570. U.S. 5,554,570 and Kokai 8-236518 have already been made of record by the examiner's office action of October 24, 2002. Reference #3 cited in the Japanese Office Action (Kokai 10-163195) corresponds to U.S. 6,133,162. Japanese Kokai 10-189577 corresponds to EP 851480 cited here. Both of the documents cited here were first brought to applicants' attention by this Japanese Office Action dated February 17, 2004.

The undersigned hereby states that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a

counterpart foreign application not more than three months prior to today's filing of this
Information Disclosure Statement

Respectfully submitted,


George A. Loud
Reg. No. 25,814

Dated: April 20, 2004

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EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.